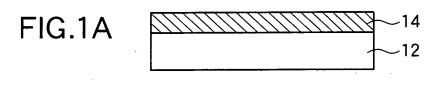
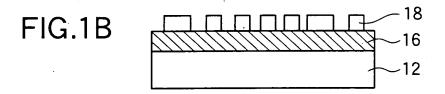
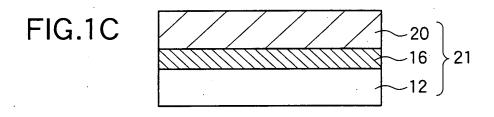
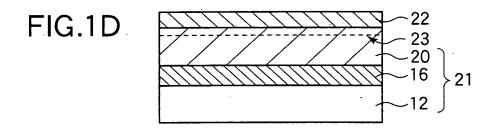
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FIG.2A

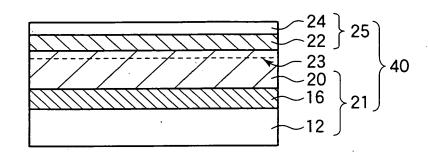


FIG.2B

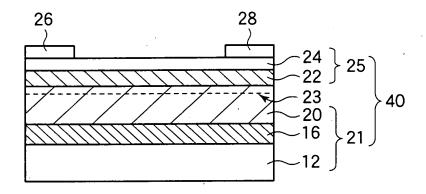
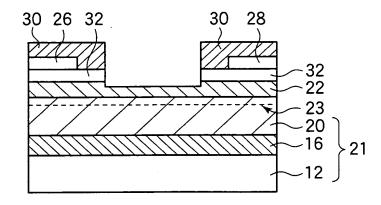


FIG.2C



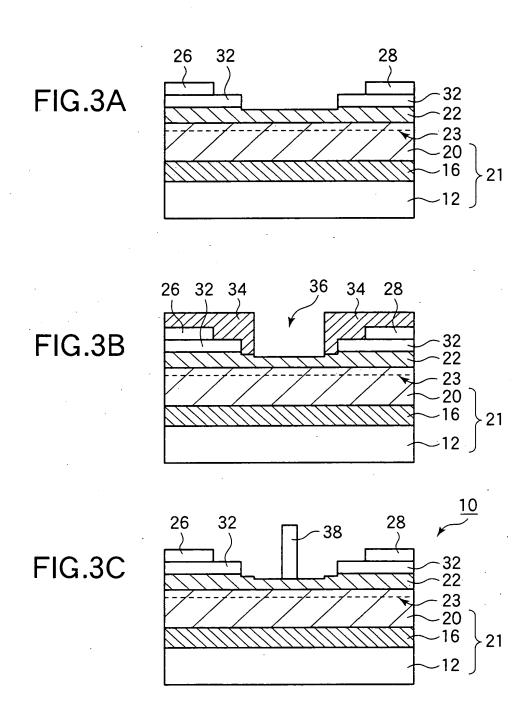
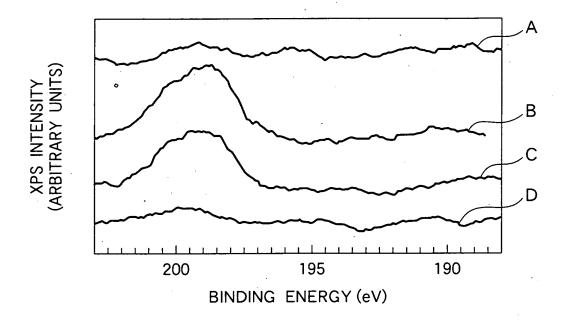
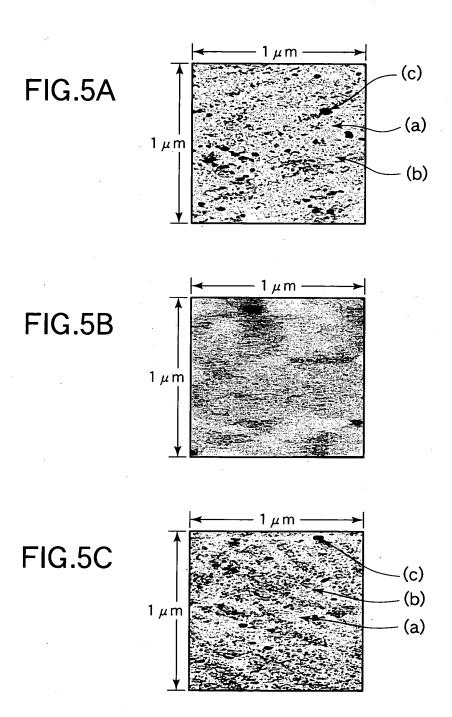


FIG.4



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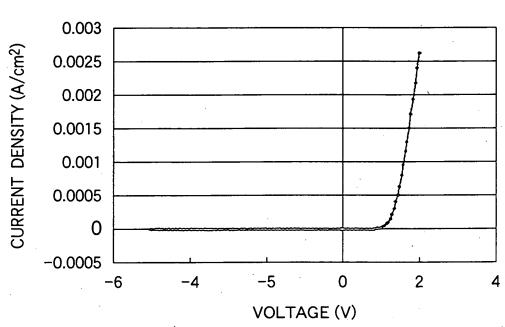


FIG.6B

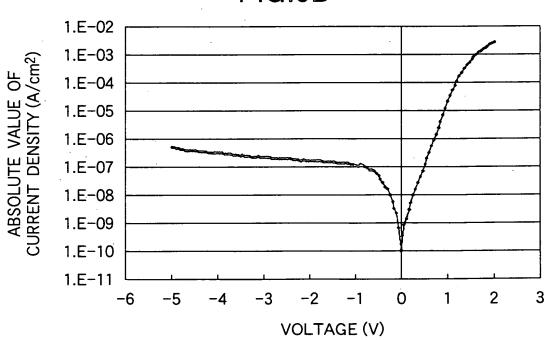
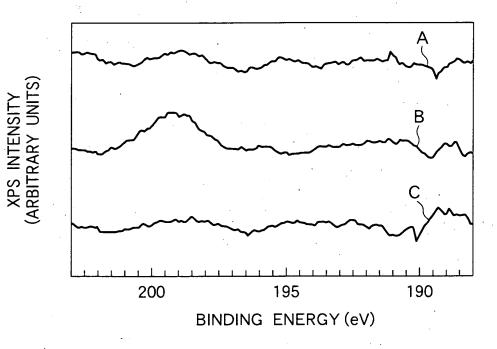
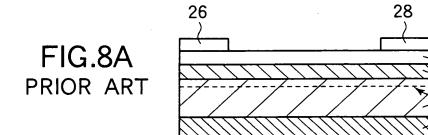


FIG.7

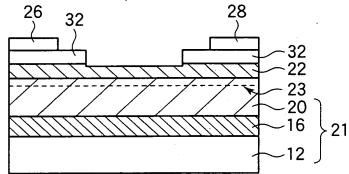


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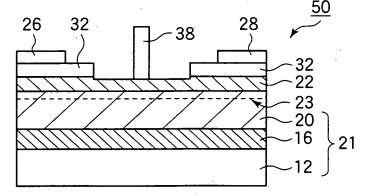
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FIG.9 PRIOR ART

